

PATENT
Atty. Dkt. No. AMAT/2956.X2/DSM/BCVD/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Rathi, et al.

Serial No.: 09/165,248

Confirmation No.: 7619

Filed: October 1, 1998

**For: A Silicon Carbide Deposition for
Use as a Barrier Layer and an
Etch Stop**

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2823

Examiner: George R. Fourson III

**CERTIFICATE OF FACSIMILE
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9/24/03
Date

Ken
Signature

RESPONSE TO FINAL OFFICE ACTION DATED JULY 29, 2003

In response to the Final Office Action dated July 29, 2003, having a shortened statutory period for response set to expire on October 29, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/2966.X2/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

The Pending Claims begin on page 2 of this paper. **Remarks/Arguments** begin on page 4 of this paper.

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DATE: September 24, 2003
FILE NO: AMAT/2966.X2/DSM/BCVD/JW
TO: Examiner: George R. Fourson III
FAX NO: 703-308-7382
COMPANY: USPTO
FROM: Keith M. Tackett / Brian K. Hrna
PAGE(S) with cover: 7
ORIGINAL TO FOLLOW? ☐ YES ☒ NO

RESPONSE TO FINAL OFFICE ACTION DATED JULY 29, 2003

TITLE: A Silicon Carbide Deposition for use as a Barrier Layer and an Etch Stop
U.S. SERIAL NO.: 09/165,248
FILING DATE: October 1, 1998
INVENTOR: Rath, et al.
EXAMINER: George R. Fourson III
GROUP ART UNIT: 2823
CONFIRMATION NO.: 7619

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